



*gm 2828*  
**PATENT APPLICATION**

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date July 27, 2005

In re the Application of

Fumio KOYAMA et al.

Group Art Unit: 2828

Application No.: 10/026,637

Examiner: A. RODRIGUEZ

Filed: December 27, 2001

Docket No.: 111587

For: SURFACE EMITTING SEMICONDUCTOR LASER AND MANUFACTURING METHOD  
THEREOF

**LARGE ENTITY PETITION FOR 1<sup>st</sup> - 3<sup>rd</sup> EXTENSION  
OF TIME UNDER 37 C.F.R. §1.136(a) AND  
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired July 7, 2005, an extension of time for a period of 1 month is hereby requested. Attached hereto is our Check No. 169163 in the amount of \$120.00 in payment for:

X  Extension fee for response within first month pursuant to §1.136(a) (\$120.00)  
  Extension fee for response within second month pursuant to §1.136(a) (\$450.00)  
  Extension fee for response within third or subsequent month pursuant to §1.136(a) (\$1020.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

07/28/2005 HALI11 00000112 10026637

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Respectfully submitted,

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JAO:TMN/tje

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DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461
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